JC05 Rec'd PCT/PTO 11 OCT 2005 10/552539

IN THE CLAIMS

Please amend the claims as follows:

- 1. (currently amended) A method for producing a preform for optical fibers [by], said method comprising: producing a fluorine-doped SiO₂ cladding glass [(4)] on a core glass cylinder [(3)] rotating about [its] a longitudinal axis thereof, including feeding [in-that] a plasma burner [(1) is fed] with a silicon-containing starter substance, said starter substance being [is] oxidized in a plasma flame [(2) assigned to] of the plasma burner [(1)] to obtain SiO₂ particles, and depositing the SiO₂ particles [are deposited] in layers on a [the] cylindrical outer surface of the core glass cylinder [(2)] in the presence of fluorine and sintering said SiO₂ particles deposited [are sintered] into the cladding glass [(4)], wherein [eharacterized in that a] said plasma flame [(2) which] emits ultraviolet light [of] in one or more wavelengths in a range about a wavelength of 214 nm [with] at an intensity of at least 0.9 μW, determined on the basis of [the] a plasma flame intensity measurement, [is used for] during the forming and depositing of the SiO₂ particles on the core glass cylinder [(3)].
- 2. (currently amended) The method according to claim 1, [characterized in that a]

 wherein the plasma flame [(2) is used which] emits said ultraviolet light [of a wavelength

 of 214 nm with] at an intensity ranging from 1.0 μW to 1.4 μW.
- 3. (currently amended) The method according to [any one of the preceding claims, eharacterized in that] claim 1, wherein the cylindrical outer surface of the core glass cylinder [(3)] is kept at a surface temperature ranging from 1550°C to 2000°C during

deposition of <u>the</u> SiO₂ <u>particles</u>, and [that] <u>wherein</u> the core glass cylinder [(3)] has an outer diameter of at least 40 mm.

- 4. (currently amended) The method according to claim 3, [eharacterized in that]

 wherein the cylindrical outer surface of the core glass cylinder [(3)] is kept at a surface

 temperature ranging from 1700°C to 1900°C during deposition of the SiO₂ particles, and

 [that] wherein the core glass cylinder [(3)] has an outer diameter of at least 60 mm.
- 5. (currently amended) The method according to <u>claim 1, wherein</u> [any one of the preceding claims, characterized in that] the SiO₂ particles are deposited on the cylindrical outer surface in layers <u>having</u> [with] a layer thickness [in] such [a manner] that <u>optical</u> <u>fibers derived from the preform have optical fiber</u> [they yield] layers <u>yielded by the layers</u> <u>of the deposited SiO₂ particles, and said optical fiber layers have respective</u> [with] layer thicknesses of not more than 0.05 μm in the optical fibers.
- 6. (currently amended) A method for producing a preform for optical fibers [by], said method comprising:

providing a cladding glass tube [consisting] of fluorine-doped quartz glass for cladding a core glass cylinder, wherein said cladding glass tube is produced by supplying [with] a silicon-containing starter substance [being supplied] to a plasma burner [for producing the cladding glass tube], said plasma burner having a plasma flame that oxidizes said substance [being oxidized in a plasma flame assigned to the plasma burner to form] forming SiO₂ particles, [and the] said SiO₂ particles being deposited in layers in the presence of fluorine on a [the]

cylindrical outer surface of a substrate tube which is rotating about [its] a
longitudinal axis thereof and is made from quartz glass, and wherein said particles
[being-] are sintered, [characterized in that the]

collapsing said cladding glass tube [is collapsed-] onto [the] said core glass

[that the] removing said substrate tube [is removed-] prior to collapsing said cladding glass tube.

7. (currently amended) The method according to claim 6, [eharacterized in that the]
wherein said substrate tube is removed by etching.

cylinder, and

- 8. (currently amended) The method according to claim 6 or 7, [characterized in that the]

 wherein said substrate tube is etched off during production of the cladding glass tube by introducing an etching gas.
- 9. (currently amended) The method according to claim 8, [eharacterized in that] wherein said etching gas is SF₆ [is used as the etching gas].
- 10. (currently amended) The method according to <u>claim</u> [any one of claims] 6 [to 9], [characterized in that a] wherein said substrate tube [is used having] has a wall thickness ranging from 2 mm to 10 mm.